

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 239690US2RD		SERIAL NO. 10/609,392 NEW APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Jun YAMAUCHI, et al.			
				FILING DATE HEREWITH 7-1-03		GROUP 2815	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	55-25492	07/04/80	Japan (with English Abstract)			x
	AP	55-28215	07/26/80	Japan (with English Abstract)			x
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Jun YAMAUCHI, et al., "First-Principles Study on Indium atoms in Silicon", 26 <sup>th</sup> INTERNATIONAL CONFERENCE ON PHYSICS OF SEMICONDUCTORS ABSTRACT, July 29, 2002, page 115					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner <i>E. J. Henderson</i>					Date Considered 8-20-04		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							